



[10191/3939]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventors : Andrea URBAN et al.  
Serial No. : 10/520,886  
Filed : July 21, 2005  
For : A LAYER SYSTEM COMPRISING A SILICON LAYER  
AND A PASSIVATING LAYER, A METHOD FOR  
PRODUCING A PASSIVATING LAYER ON A SILICON  
LAYER AND THEIR USE  
Examiner : Laura M. Schillinger  
Art Unit : 2813  
Confirmation No. : 7030

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

Date: June 30, 2008

Reg. No. 36,197

Signature: \_\_\_\_\_

Jong H. Lee

**AMENDMENT**

SIR:

In response to the final Office Action mailed on January 2, 2008, please reconsider the above-identified application based on the following. A three-month extension of time for filing a reply is requested. Please charge the \$1,050 extension fee to Kenyon & Kenyon LLP's Deposit Account No. 11-0600.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.

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